7V Tristate-Capable Output Buffer Implemented in Standard 2.5V CMOS Process

Vladimir Prodanov and Vito Boccuzzi

Bell Laboratories/ Lucent Technologies
600 Mountain Ave., Murray Hill, NJ 07974

Abstract

This paper describes high-voltage CMOS buffer architecture that uses low-voltage transistors. The voltage capability of presented architecture is nearly three times larger than the voltage capability of used MOSFET's. This buffer topology could be used to provide $3.3V$ compatibility of $1.2V$ and $1.5V$ digital ICs implemented in standard CMOS technology. A $7V$ circuit-prototype was fabricated in $0.25\mu m$ $2.5V$ CMOS technology. Performed measurements demonstrate stress-free operation in both active and high-impedance mode.

Introduction

As CMOS technology scales below $0.2\mu m$, allowed supply voltages become significantly lower than previous $3.3V$ and $5V$ standards [1]. Because of economic reasons, systems usually use chips spanning several technology generations. As a result, a $3.3V$ IC might need to interface with another IC designed to operate from lower supply voltage (such as $1.5V$). This scenario presents a serious problem: *The buffer circuits of the $1.5V$ IC neither can provide nor sustain (when in high-impedance state) a $3.3V$ drive.*

One could solve the above problem in two ways. The first approach is to use "dual-supply" technology. However, the use of technology that has two types of transistors[1] such as $1.5V$(low-voltage) and $3.3V$ (high-voltage) devices, increases production cost[2].

The second approach is to develop buffer architectures that have high-voltage capabilities and use only low-voltage transistors. Reported to date *high-voltage buffers with low-voltage transistors* (HVB/LVT) can be classified into two basic groups: 1) circuits with both high-voltage tolerance and high-voltage drive; 2) circuits with high-voltage tolerance and low-voltage drive. The conceptual schematics of these two types of HVB/LVT's are shown in Fig. 1. The pad driver in Fig. 1(a) consists of n-channel and p-channel cascode stacks. The cascodes allow output to traverse between 0 and V_{high} while the V_{gs}'s and V_{gd}'s of all four transistors remain lower than $1/2V_{high}$ [2]. Thus, the voltage capability of Fig. 1(a) pad driver is two times larger than the voltage capability of used MOSFET's. For

---

[1]Many sub-$0.2\mu m$ technologies are "dual-supply" technologies.
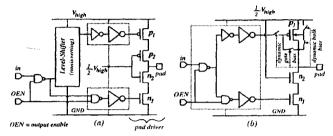[2]This increase could be as much as 20%.

Figure 1: Conceptual schematics of high-voltage tristate-capable output buffers: (a) with $2X$ drive and $2X$ tolerance; (b) with "regular"($1X$) drive and $2X$ tolerance;

proper operation the cascode pad driver requires two in-phase input signals. Both signals must have low-voltage ($1/2V_{high}$) swing. These signals are provided through two "regular" inverter chains and are generated by the level-shifter circuit. The level-shifter takes a $0-to-1/2V_{high}$ input and produces signal that swings between $1/2V_{high}$ and V_{high}. Naturally, the level-shifter must be implemented in such a way that none of its transistors experiences voltage overstress.

Unlike previously discussed HVB/LVT the circuit shown in Fig. 1(b) is biased from the lower supply voltage. As a result its output drive is only $0-to-1/2V_{high}$. The structure however allows pad voltage to exceed supply (when the buffer is in tristate mode), i.e. the circuit has high-voltage tolerance ($\approx V_{high}$). Three problems have been eliminated to achieve this $2X$ tolerance [3]: *1) V_{dg} overstress of n-channel transistor; 2) conduction of p-channel transistor; 3) forward biasing of the drain-bulk pn junction of p-channel transistor.* The first problem is resolved by using an n-channel cascode, while the second and the third are eliminated by using dynamic gate and bulk biasing (conceptually illustrated using two pairs of switches).

Recently, two HVB/LVT's with beyond-$2X$ voltage capabilities have been reported. Clark [4] has developed circuit with $3.3V$ drive and $5V$ tolerance using $2V$ transistors, while Singh and Salem [5] have extended the stress-free range of a cascode stack beyond supply and ground with approximately one threshold voltage. Both circuits use dynamic gate biasing .

In the next two Sections we will describe an HVB/LVT that has a stress-free range of nearly $3X$. Its high-voltage

23-4-1

capability is achieved by means of suitable dynamic gate biasing.

High-Voltage Pad Driver

The conceptual schematic of pad driver having stress-free range of $3X$ is shown in Fig. 2(a). In this circuit the pad voltage controls S_1 and S_2 switches[3] which provide dynamic gate biasing for the triple cascode. None of the used six transistors will experience V_{gs} or V_{dg} voltage overstress if the following conditions are satisfied:

	Turns ON/OFF	Stays ON
S_1	$1/3V_{high} < V_{pad} < 2/3V_{high}$	$V_{pad} < 1/3V_{high}$
S_2	$1/3V_{high} < V_{pad} < 2/3V_{high}$	$V_{pad} > 2/3V_{high}$

The fact that S_1 must be ON when its control voltage (i.e. V_{pad}) is lower than the switch terminal voltages suggests that S_1 should be implemented using p-channel transistor. S_2 on the other hand should be implemented using n-channel transistor because it must be ON when its control voltage is higher than its terminal voltages.

The gates of both switch transistors should be controlled by V_{pad}, but they <u>can not</u> be directly connected to the pad node[4]. For stress-free operation the gate voltage of p_{S1} must follow V_{pad} but it should never exceed $2/3V_{high}$. Similarly, the gate voltage of n_{S2} must follow V_{pad} but it should never go below $1/3V_{high}$. When Fig. 2(a) pad driver is in tristate mode, nodes "1" and "2" have the required voltage excursions[5].

The above observations lead to Fig. 2(b) pad driver. The circuit was simulated using models for Lucent's $0.25\mu m$ 2.5V technology and V_{high} of 7.5V. It was placed in tristate mode (i.e. both n_1 and p_1 - OFF) and the pad voltage was varied between 0 and 7.5V. As expected, the gate-source and gate-drain voltages of all eight transistors remain bounded to $\pm 2.5V$. Unfortunately, in active mode V_1 is not only function of V_{out} (i.e. V_{pad}) but it is also function of the gate voltage of transistor n_1 (i.e. V_{gn1}). Similarly, V2 is function of both V_{pad} and V_{gp1}. As a result, immediately after each input transition both p_{S1} and n_{S2} are ON and conducting large "shot-trough" current. More importantly, during the same time the gate oxides of both n_3 and p_3 are subjected to voltage overstress. This problem is eliminated in the circuit of Fig. 2(c). Here, the triple cascode is split into two separate circuits, one of them is always operated in tristate and the switching transistors are shared. The controls for the switching transistors are derived from the "always-tristate" circuit. Switch transistors p_{S1} and n_{S2} respond only to changes in V_{pad} and provide dynamic protection for transistors n_{3A} and p_{3A}. However, since the drain and gate nodes of these two

---

[3] S_1 and S_2 must not be ON at the same time.

[4] Direct connection would result in voltage overstress of switch transistors.

[5] V_1 follows V_{pad} down to ground, but it would not increase much beyond $2/3V_{high} - V_{tn}$. V_2 on the other hand follows V_{pad} to supply rail but it would not decrease significantly below $1/3V_{high} + V_{tp}$.
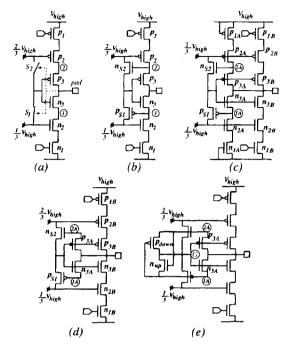

Figure 2: Evolution of $3X$ pad driver: a) conceptual schematic. b) implementation that works well in tristate mode but fails in active mode. c) implementation that works well both in tristate and active modes. d) reduced topology. e) topology where the DS overstress of transistors n_{3A} and p_{3A} has been eliminated.

transistors are coupled respectively to the gate and drain nodes of n_{3B} and p_{3B} the switches also provide protection for n_{3B} and p_{3B}. Eliminating the "unused" n_{1A}, n_{2A}, p_{1A} and p_{2A} we obtain the HVB/LVT shown in Fig. 2(d).

The gate-source (GS) and gate-drain (GD) voltages of all ten transistors are always limited to $\pm 1/3V_{high}$. Unfortunately, drain-source (DS) voltages of transistors n_{3A}, p_{3A}, n_{3B} and p_{3B} exceeds $1/3V_{high}$ (by at least one threshold voltage).

To keep V_{ds} of $n_{3A} \leq 1/3V_{high}$ we have to pull node "1A" up to $2/3V_{high}$. This is accomplished in Fig. 2(e) via transistor n_{up}. Similarly, to keep Vds of $n_{3A} \leq 1/3V_{high}$ we have to pull node "2A" down to $1/3V_{high}$ which is accomplished via transistor p_{down}. Note that when activated n_{up} does not connect "1A" directly to $2/3V_{high}$. Instead, it connects it to node "G" which for high pad voltages acquire desired $2/3V_{high}$ value. Similarly, node "2A" is brought down to $1/3V_{high}$ via node "G", i.e. indirectly. This is intentionally done in order to guarantee that transistors n_{up} and p_{down} are not stressed.

The final problem that needs to be addressed is the drain-source overstress of transistors n_{3B} and p_{3B}. We will briefly discuss what causes the drain-source overstress of transistor n_{3B} and we will provide circuit solution to this problem[6].

When the pad voltage equals V_{high} the drain-source

---

[6] The p_{3B} case is analogous and will not be discussed here.
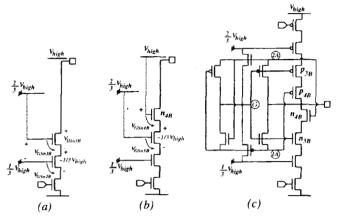
Figure 3: Evolution of $3X$ pad driver with no DS overstress of transistors n_{3B} and p_{3B}.

(a)

(b)

Figure 4: High-voltage level-shifter using impulse-driven RS latch: (a) conceptual schematic; (b) an implementation based upon a "one-shot" circuit;

voltages of transistors n_{2B} and n_{3B} (see Fig. 3(a)) are: $V_{DSn2B} = 1/3V_{high} + (V_{GSn2B} - V_{GSn3B})$ and $V_{DSn3B} = 1/3V_{high} + V_{GSn3B}$ respectively. Immediately after input transition both V_{GSn2B} and V_{GSn3B} increase so that cascode transistors could carry the current conducted by n_{1B}. These changes would alter V_{DSn2B} and V_{DSn3B}. According to the first equation, the change in V_{DSn2B} can be kept low (thus V_{DSn2B} could be kept approximately constant and equal to $1/3V_{high}$) by making n_{2B} and n_{3B} identical in size. The second equation reveals that n_{3B} would experience an overstress of V_{GSn3B}. This overstress could be prevented by connecting an additional cascode transistor as shown in Fig. 3(b). With n_{4B} in place, drain-source voltage of n_{3B} becomes $V_{DSn3B} = 1/3V_{high} + (V_{GSn3B} - V_{GSn4B})$. This drain-source voltage can now be kept nearly constant and equal to $1/3V_{high}$ by simply making n_{4B} and n_{3B} identical in size. This drain-source overstress protection requires gate of n_{4B} to have potential of V_{high} whenever the pad node has potential V_{high}. The gate potential of transistor n_{4B} should however be lowered to $1/3V_{high}$ as pad node traverses toward ground, i.e. n_{4B} requires a $V_{high} - to - 1/3V_{high}$ dynamic gate biasing. Such biasing is readily available - node "2A" in Fig. 2(e) circuit.

Similarly, the drain-source overstress of p_{3B} is eliminated by the addition of p_{4B} cascode transistor. As shown in Fig. 3(c) required dynamic biasing $(0 - to - 2/3V_{high})$ is obtained by directly connecting the gate of transistor p_{4B} to node "1A".

The Level-Shifter Circuit
Level-shifter consists of two inverters and an RS latch (see Fig. 4(a)). Each inverter is comprised of input transistor (n_{inA} & n_{inB}), a cascode stack (the n_c's) and load transistor (n_{LA} & n_{LB}). Cascode transistors provide overstress protection for the input devices. For effective overstress protection all devices must have the same size. With
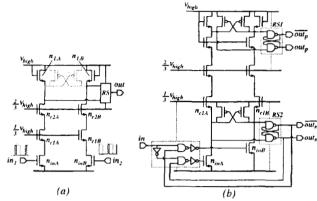
equally sized input and load transistors, Fig. 4(a) inverter structures exhibit gain of near-unity for large signals. Inverter gain is on first order insensitive to process and temperature variations. Fig. 4(a) level-shifter architecture however dissipates (static) power.

The static power dissipation could be reduced if the two inverters are impulse driven. To minimize static power consumption we have to minimize input pulse duration[7]. If the two inverter structure are pulse driven both inverter outputs will be "high" most of the time. In order to be able to retain its state, the latch must be implemented using $NAND$ gates (as opposed to NOR gates).

Schematic of the complete level-shifter circuit is shown in Fig. 4(b). Desired impulse drive is realized using a "one-shot" circuit. This circuit employs three MOS inverters, two $NAND$ gates and a $NAND$-based RS latch ($RS2$). Transistors n_{inA}, n_{inB}, n_{c1A} and n_{c1B} are also part of the one-shot circuit[8]. Pulse is produced at the gate of transistor n_{inA} (n_{inB}) whenever there is positive (negative) input transition. The duration of the produced pulse is approximately equal to $\tau_{MOS} + \tau_{n_{in}/n_{c1}} + \tau_{RS}$; where τ_{MOS} is the delay of the MOS inverter, $\tau_{n_{in}/n_{c1}}$ is the delay of the $n_{in} - n_{c1}$ inverter and τ_{RS} is the switching delay of the used RS latch. As long as RS1 and RS2 are equally loaded and present minor loading to their corresponding driving circuits, the duration of the generated driving pulses would be sufficient to guarantee switching of latch RS1.

Experimental Results
Tristate-capable $7V$ output buffer (see Fig. 5) was fabricated with Lucent's $0.25\mu m$ $2.5V$ CMOS process. The circuit was designed to drive $10pF$ of load capacitance at $200MHz$. Pad driver transistor sizes (all in μm) are as

---

[7]Pulse duration however should be sufficiently large so that RS latch could change its state.

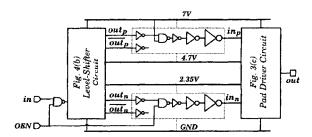[8]The two-transistor structures $n_{inA} - n_{c1A}$ and $n_{inB} - n_{c1B}$ can be viewed as inverters.

Figure 5: Schematic of complete 7V/2.5V CMOS output buffer.

follows:

n_{1B-4B}	370/0.24	p_{1B-4B}	1300/0.28
n_{3A}, n_{up}	37/0.24	p_{3A}, p_{down}	74/0.28
n_{S2}	740/0.24	p_{S1}	1300/0.28

The circuit was tested extensively. Twenty three packaged parts (out of 25 tested) were functional. On-wafer probing was also performed successfully. To verify high-voltage capability, internal nodes ($1A$, $2A$ and G) had to be measured while the buffer was being operated in "package-like environment"[9]. The obtained waveforms were then compared to output (pad) waveform. The potential differences $V_{out} - V_{1A}$, $V_{out} - V_{2A}$ and $V_{out} - V_G$ are indicative of presence/absence of GS-GD voltage overstress. These differences indeed remain bounded to approximately $\pm 2.5V$ (see Fig. 6 and Fig. 7).

Conclusion

We have presented high-voltage output buffer. The voltage drive and tolerance of the developed circuit is nearly three times larger than that of used MOS devices. The circuit has been experimentally verified in $0.25\mu m$ $2.5V$ CMOS process, but it can be used in any other CMOS process. The use of proposed architecture entails performance-cost trade-off[10].
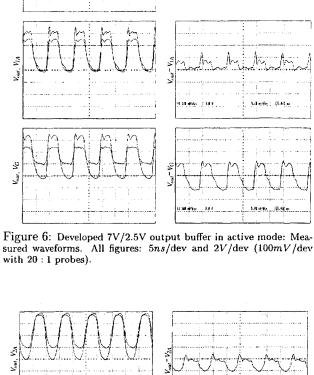
References

[1] The 1999 International Technology Roadmap for Semiconductors.

[2] T. Oka et al., "Semiconductor Circuit Having MOS Circuit for Use in Strong Electric Field," US Patent 5,663,917, Sept. 1997

[3] M. Pelgrom and E. Dijkmans, "A 3/5V Compatible I/O Buffer," *IEEE J. of Solid-State Circuits*, vol. 30, No. 7, pp. 823-825, Jul. 1995.

[4] L. Clark, "High-Voltage Output Buffer Fabricated on a 2V CMOS Technology," *Digest of Technical Papers, 1999 VLSI Symposium*, pp. 61-62.

[5] G. Singh and R. Salem, "High-Voltage-Tolerant I/O Buffers with Low-Voltage CMOS Process," *IEEE J. of Solid-State Circuits*, vol. 34, No. 11, pp. 1512-1525, Nov. 1999.
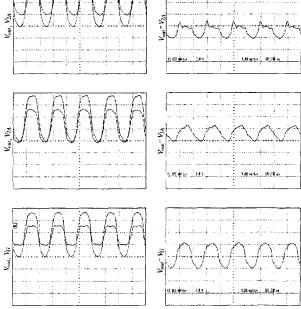
---

[9] This was done by bonding a bare die directly on a PCB and using active (Pico) probes.

[10] No dual-supply technology is required, but the performance is inferior to that of a "regular" buffer implemented with high-voltage devices.

Figure 6: Developed 7V/2.5V output buffer in active mode: Measured waveforms. All figures: 5ns/dev and 2V/dev (100mV/dev with 20 : 1 probes).

Figure 7: Developed 7V/2.5V output buffer in tristate mode: Measured waveforms. All figures: 5ns/dev and 2V/dev (100mV/dev with 20 : 1 probes).

23-4-4